



2877

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Bruce et al. Examiner: Turner, S.
Serial No.: 09/386,112 Group Art Unit: 2877
Filed: August 30, 1999 Docket No.: AMDA.261PA
Title: DUAL-DIFFERENTIAL INTERFEROMETRY FOR SILICON DEVICE
DAMAGE DETECTION

#8 / Q
w/ Drugs.
Marsha
1/10/01

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this communication is being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on December 22, 2000.

By: Lynda J. Bauer
Lynda J. Bauer

OFFICE ACTION RESPONSE

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated September 22, 2000, please amend the above-identified patent application as follows:

In The Drawings:

Please replace FIG. 2 with amended FIG. 2 attached hereto.

In The Specification:

On page one, in the title of the invention, change "INTERFROMETRY" to --INTERFEROMETRY--. This change is reflected in the title listed hereinabove.

On page 6, line 5, change "interfrometry" to --interferometry--.

In The Claims:

Please amend the claims as follows:

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